Technical Sessions At-a-Glance Wednesday December 7, 2011 12:00 - 7:00 PM Registration - Grand Ballroom Lounge Room Colony Ballroom Charles Carroll Room Benjamin Banneker Room Juan Ramon Jimenez Room Margaret Brent Room Prince Georges Room WP1: Nanoelectronics I: WP2: Wide Bandgap I: WP4: Photovoltaics/Electronics for WP5: Optics and Optoelectronics 1:30-3:30 PM WP3: Oxides and Dielectrics **UV** Emitters Novel Devices Energy WP6: Nanoelectronics II: WP7: Wide Bandgap II: WP9: Organic Materials and 3:45-5:45 PM WP8: Oxides and Dielectrics II WP10: Novel Devices I 2D Materials and Memory Nitride Optoelectronics Devices Welcome Reception and Poster Session - Grand Ballroom 6:00-8:30 PM Thursday December 8, 2011 7:30 AM - 5:00 PM Registration - Grand Ballroom Lounge Plenary Session - Colony Ballroom James Speck, University of California, Progress in Nonpolar and Semipolar GaN Materials and Devices 8:30-10:15 AM H.-S. Philip Wong, Stanford University, Emerging Memory Devices Room Colony Ballroom Charles Carroll Room Benjamin Banneker Room Juan Ramon Jimenez Room Margaret Brent Room Prince Georges Room TA2: Wide Bandgap III: Device 10:45 AM -12:15 PM TA1: Nanoelectronics III TA3: Sensors, NEMS, and MEMS TA4: Flexible Electroinics TA5: Processing Technology Physics and Characterization 12:15-1:15 PM Lunch - Grand Ballroom TP2: Wide Bandgap IV: TP10: Reliability* 1:15-3:15 PM TP1: Nanoelectronics IV Wide Bandgap Materials TP3: Sensors TP5: Testing and Characterization TP4: SOI and SiGe for Optoelectronics (*Note: TP10 is intentionally **TP6:** Nanoelectronics V: **TP7:** Wide Bandgap V: 3:45-6:05 PM TP8: Low Power Electronics TP9: SiGe and Germanium out of order due to limited Nanotubes and Graphene GaN/ZnO Materials and Devices space availability) 6:15-8:30 PM Symposium Awards Banquet - Grand Ballroom

Friday December 9, 2011						
Room	Colony Ballroom	Charles Carroll Room	Benjamin Banneker Room	Juan Ramon Jimenez Room	Margaret Brent Room	Prince Georges Room
8:00 – 10:00 AM	FA1: Nanoelectronics VI: Nanotubes and Graphene	FA2: Wide Bandgap VI: SiC Materials and Devices	FA3: Nanowires, Assembly Methods and Devices I	FA4: Modeling & Simulation I		
10:15 AM – 12:25 PM	FA5: Nanoelectronics VII: Nanotubes and Graphene	FA6: Wide Bandgap VII: III-Nitride HEMTs	FA7: Nanowires, Assembly Methods and Devices II	FA8: Modeling & Simulation II		
12:25-1:15 PM	Lunch (on your own)					
1:15–3:15 PM	FP1: Optics, Optoelectronics and Plasmonics	FP2: Space and Extreme Environment Electronics	FP3: Novel Devices II	FP4: Modeling & Simulation III		
	Plasmonics	Environment Electronics				